

<b>Notice of References Cited</b>	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10/729,006	TOYOMURA, FUMITAKA
Examiner	Art Unit	
Asha.Hall	1753	Page 1 of 1

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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)	
	U	Jackson et al., Handbook of Semiconductors Technology, Vol. 2., Wiley, Copyright 2000, p.348.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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